



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIMOTO et al

Serial No.: 08/897,839

Filed: July 21, 1997

For: STRESS-ADJUSTED INSULATING
FILM FORMING METHOD,
SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING THE
SAME

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) Art Unit: 2823
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) Examiner: K. Eaton
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#32

Ext. 2 mos.

Jim Crivello

12/11/02

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DEC - 6 2002
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PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

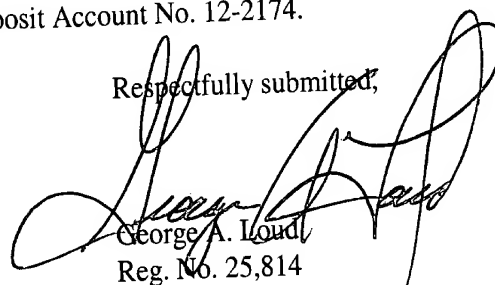
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a Notice of Appeal in response to the final action of July 12, 2002, initially set to expire October 12, 2002, be extended two months up to and including December 12, 2002. The requisite \$400.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to Deposit Account No. 12-2174.

Respectfully submitted,


George A. Loud
Reg. No. 25,814

12/05/2002 AWONDAF1 00000114 08897839

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400.00 DP

Date: December 4, 2002

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